

EEE337 Semiconductor Electronics EEE348 Electronics and Devices

Professor Chee Hing Tan

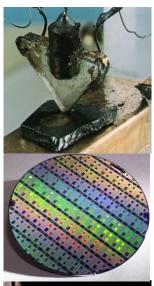
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Outline



- Module Background
- Why semiconductor?
- Energy levels in an isolated hydrogen atom
- Band structure



1 µm



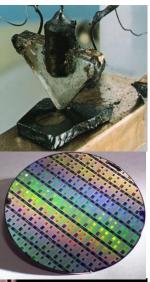
Lecture delivery plan

- Review semiconductor band structure, doping, conduction, junctions
- Introduce the various electronic material systems (Si, Ge, III-V, SiC, GaN) and outline their electronic properties and principal applications
- Heterojunctions
- Review Solar Cell developments
- Introduce optical detector technologies and applications for different wavelength ranges
- Demonstrate performance and functional improvements possible using heterojunctions
- Explore heterostructure optoelectronic devices such as Lasers, LEDs
- Introduce the physics of high speed devices
- Describe how tunneling, Gunn and impact ionisation effects leads to negative differential resistance

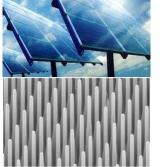
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Module details







Time Allocation

24 lectures, 12 problem classes, 62 hours independent study.

Recommended Previous Courses

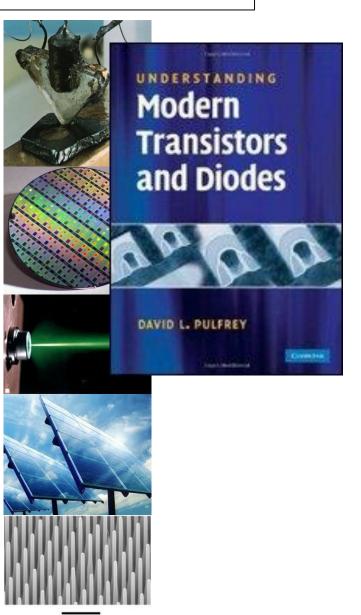
Knowledge equivalent to EEE118, EEE225.

Assessment

3 out of 4 questions on 2 hour examination.

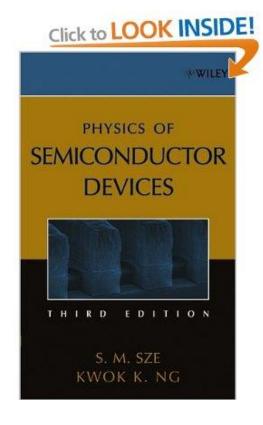


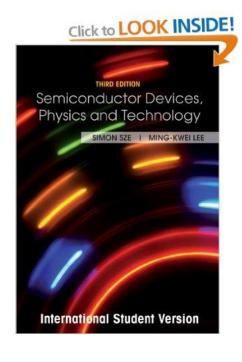
Recommended Books



Ebook:

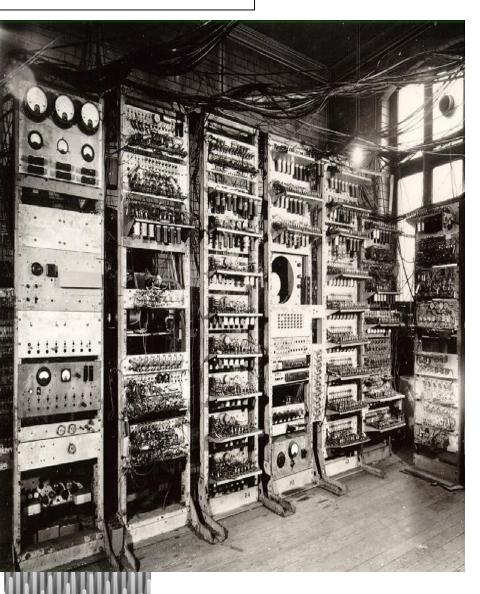
(Library-Electronic Resources-Ebooks-Ebook supplier information-Dawsonera)

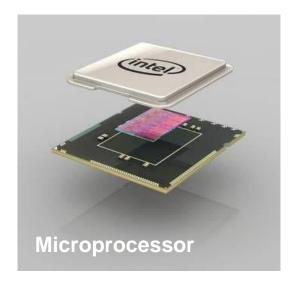






Why use semiconductor?





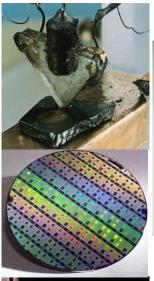
iPad mini



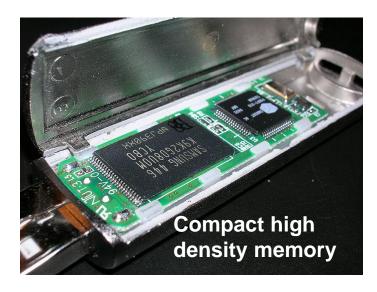
Transistors are used in logic circuits that are compact, low power consumption and affordable.



Why use semiconductor?

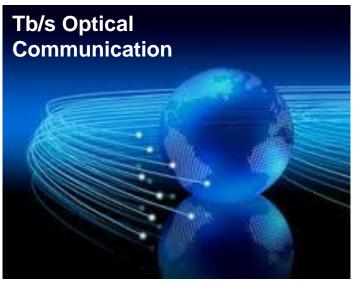






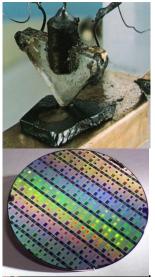




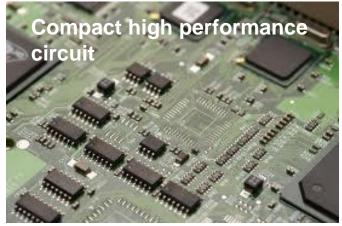




Why use semiconductor?















Semiconductor is an important driver of many technologies

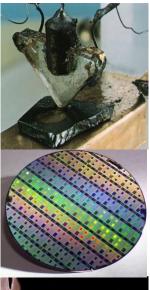


Flexible display is another exciting example of progress made in semiconductors

http://www.youtube.com/watch?v=sJehexDPEsE https://www.youtube.com/watch?v=AxbHpXE4VM0

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Revision: Basic properties of semiconductors

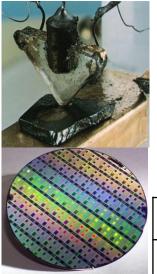


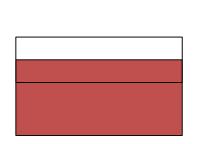
1 µm

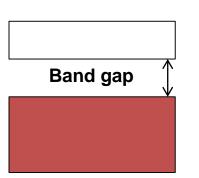
CH Tan

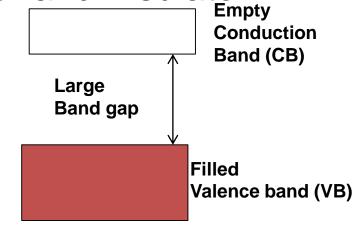


Metal, Semiconductor and Insulator











Metal

- •CB and VB overlap.
- Electrons move freely under the influence of electric field because there are many available states in the CB.
- •Good electrical conductor.

Semiconductor

- Band gap of meV to a few eV.
- •At T=0 K, no electron in the CB.
- •At 300 K, thermal energy kT = 26 meV which is a fraction of the band gap.
- Appreciable number of electrons are thermally excited to become free electrons in CB.

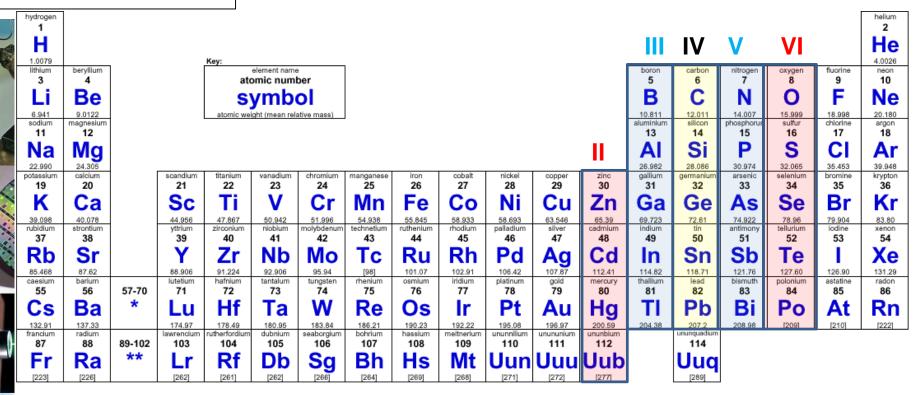
Insulator

- •Bandgap is large 9 eV (SiO₂).
- •Negligible electron in CB.
- •Cannot achieve good current conduction.

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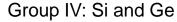
Common Semiconductors



*lanthanoids

**actinoids

lanthanum	cerium	praseodymium	neodymium	promethium	samarium	europium	gadolinium	terbium	dysprosium	holmium	erbium	thulium	ytterbium
57	58	59	60	61	62	63	64	65	66	67	68	69	70
La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Но	Er	Tm	Yb
138.91	140.12	140.91	144.24	[145]	150.36	151.96	157.25	158.93	162.50	164.93	167.26	168.93	173.04
actinium	thorlum	protactinium	uranium	neptunium	plutonium	americium	curium	berkelium	californium	einsteinium	fermium	mendelevium	nobelium
89	90	91	92	93	94	95	96	97	98	99	100	101	102
Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No
[227]	232.04	231.04	238.03	[237]	[244]	[243]	[247]	[247]	[251]	[252]	[257]	[258]	[259]



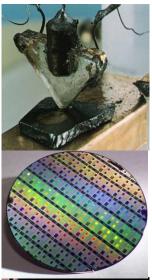
Group III-V: GaAs, InP, GaP, InAs, InSb

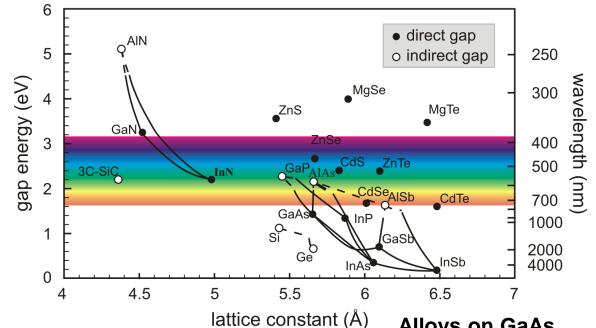
Group II-VI: HgCdTe, CdZnTe

1μm C H Tan



Semiconductor Alloys







Widely available substrates

IV Si Ge SiC III-V GaAs InP InSb

GaSb

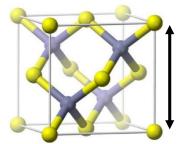
InAs

CdSe ZnSe ZnTe

II-VI

CdTe

Alloys on GaAs
AlGaAs
InGaP
AllnP



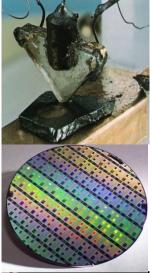
Alloys on InP
InGaAs
InAlAs
GaAsSb
AlAsSb
InGaAsP
InAlGaAs

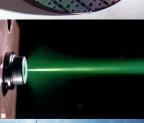
Lattice constant

1 µm



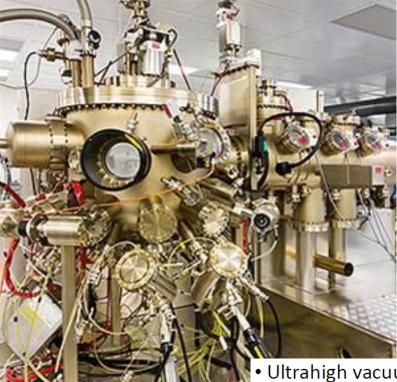
Ultra high vacuum molecular beam epitaxy

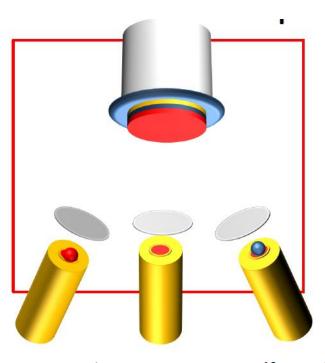






1 µm





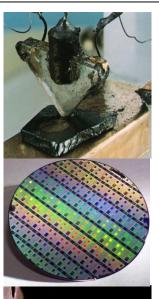
- \bullet Ultrahigh vacuum conditions (base pressure $^{\sim}10^{\text{-}10}\text{mbar}$)
- Vaporised solid ultrapure elemental sources
 - Group III: In, Ga, Al
 - Group V: (N), P, As, Sb, Bi
 - •Dopants: Si and Be
- Condense onto a heated, rotated substrate

http://www.epsrciii-vcentre.com/working-us/facilities/

Table 1. Some physical properties of important semiconductor materials Crystal-Type of Material Carrier mobility at 300°K Lattice Melting point Vapor Width of energy gap electron material volts (cm²/volt-sec) structure type constant (°c) pressure at melting point (angstrom At 0°K At 300°K Electrons Holes (atmospheres) units) 5.47 10-9 C (diamond) 5.51 1,800 1,600 Diamond 3.56679 4027 Element Ge 0.803 0.89 3,900 1.900 Diamond 5.65748 937 Si 10-6 1.12 1.16 1,500 600 Diamond 5.43086 1420 la-Sn -0.086.4892 Diamond A^{IV}B^{IV}compou 3.1 a-SiC 3 400 50 Zinc blende 4.358 3100 A^{III}B[∨] AISb 1.63 1.75 200 420 Zinc blende 6.1355 1050 < 0.02 compound ВP 4.538 >1300 >24 6 Zinc blende GaN 3.5 3.186 (a=axis) >1700 >200 Wurtzite 5.176 (*c*=axis) $<4 \times 10^{-4}$ GaSb 0.67 0.80 4,000 1,400 6.0955 706 Zinc blende GaAs 1.43 1.52 8,500 400 5.6534 1239 Zinc blende GaP 2.24 2.40 110 75 5.4505 1467 35 Zinc blende <10⁻⁵ InSb 0.16 0.26 78,000 750 Zinc blende 6.4788 525 InAs 0.33 0.46 33,000 460 Zinc blende 6.0585 943 0.33 InP 1.29 1.34 1060 25 4,600 150 Zinc blende 5.8688 A^{II}B^{VI} CdS 2.42 2.56 300 50 Wurtzite 4.16 (a=axis) 1750 6.756 (*c*=axis) compound CdSe 1.7 800 6.05 1258 1.85 Zinc blende ZnO 3.2 200 Cubic 4.58 1975 ZnS 3.6 3.7 165 3.82 (a=axis) 1700 Wurtzite 6.26 (*c*=axis) PbS 0.34 600 700 0.41 Cubic 5.935 1103 PbTe 0.32 0.24 6,000 4,000 Cubic 6.460 917 compound



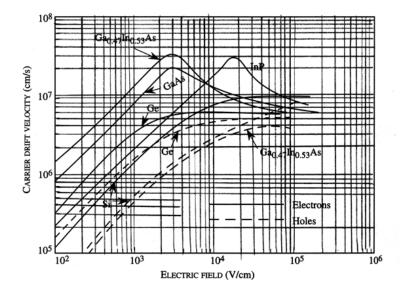
Carrier mobility





1 µm

Why is carrier mobility an important parameter?
 High mobility increases carrier drift velocity

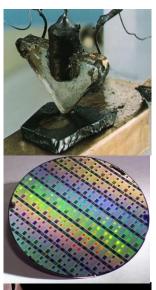


$$\frac{1}{\rho} = \sigma = q(\mu_n n + \mu_p p)$$

High mobility increases conductivity (reduces resistivity)



Speed of semiconductor devices

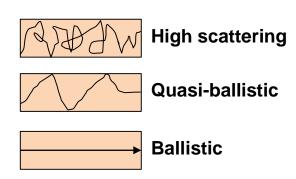


The speed of a semiconductor device fundamentally depends on the carrier transport. Carrier velocity and device size/geometry are the major factors

Carrier velocity $v = \mu E$ ($\mu = mobility$, E = electric field)

$$\mu = \frac{e\tau}{m}$$

- μ is a material dependent parameter.
- m can be for electrons or holes, which have very different mass and m-> m*, called the 'effective mass' which is material dependent
- au = carrier lifetime between scattering events (due to imperfections in the semiconductor crystal)
- To increase the speed of devices and logic circuits, we need to increase the carrier mobility.



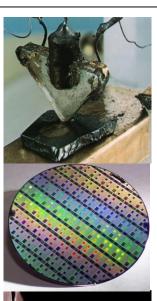
Materials from Si to graphene have been developed into high speed transistors. Mobility of 15,000 cm²V⁻¹s⁻¹ demonstrated in graphene (however the theoretical value is 200,000 cm²V⁻¹s⁻¹)

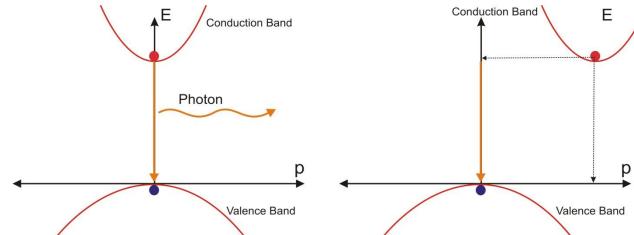


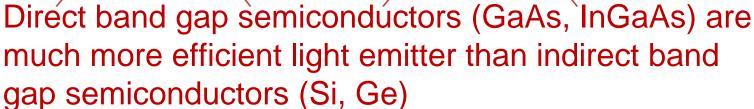
1 µm



Bandgap





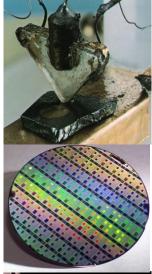




Band gap and recombination process determine the efficiency of optoelectronic devices. The emission and absorption wavelengths are also determined by the band gap.

Band gap also controls the carrier concentration (hence current) in electronic devices





How do we design and optimise electronic and optoelectronic devices?



We need the knowledge of band structure and properties of semiconductor.



P

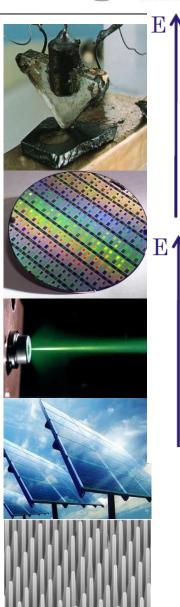
 \mathbf{S}

P

Quantised energy level

Potential energy

~0.1nm



1 µm

Fixed energy levels (quantum mechanics).
Potential energy barrier bind electrons to

→ r In an isolated hydrogen atom E_H =-13.6/n² eV

the nucleus.

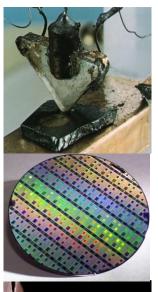
Electrons in upper states are more weakly bounded to the nucleus.

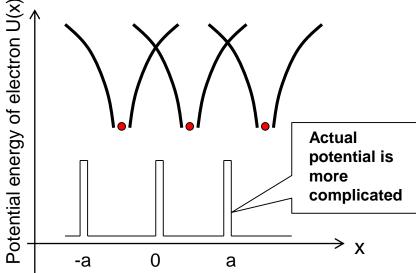
Quantum mechanics
(Pauli exclusion principle)
does not allow identical
states

→the two states split

How about in a crystal?







Presence of other electrons, different atoms, and different spacing in different directions will influence the potential energy. However the important fact is the periodicity of the potential energy.

To find the allowed energy states, in the crystal we need to treat electron as wave. The equation that produces solutions which are consistent with experiment is the time independent Schrodinger equation.

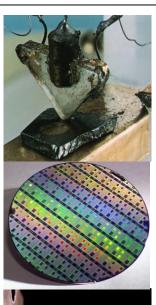
What is Schrodinger equation?

The total energy (E) is given by the sum of kinetic energy (K) and potential energy (U). So we have K+U =E. From this we can derive a wave equation as $(K+U)\Psi(x) = E\Psi(x)$

$$\frac{\hbar^2}{2m}\frac{d^2\Psi(x)}{dx^2} + U(x)\Psi(x) = E\Psi(x)$$

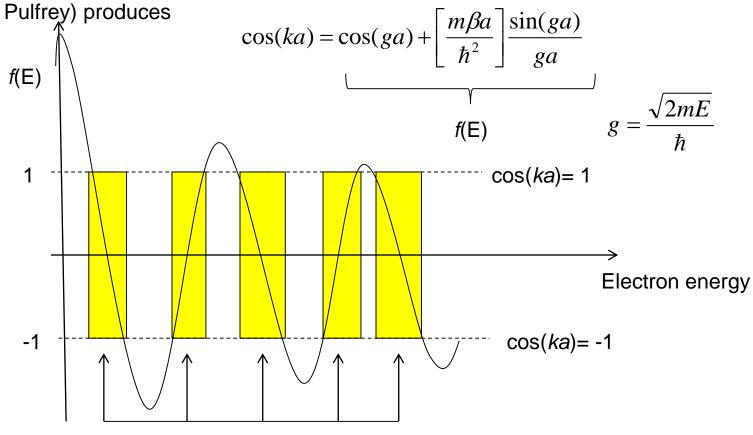
1 μm





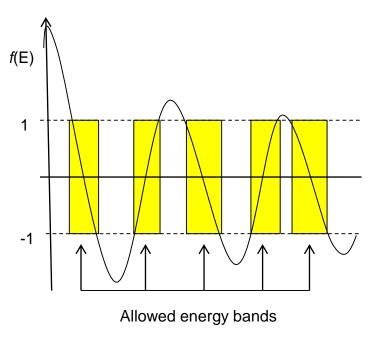
Consider a free electron with U(x) =0 gives
$$\frac{\hbar^2}{2m} \frac{d^2 \Psi(x)}{dx^2} = E \Psi(x)$$

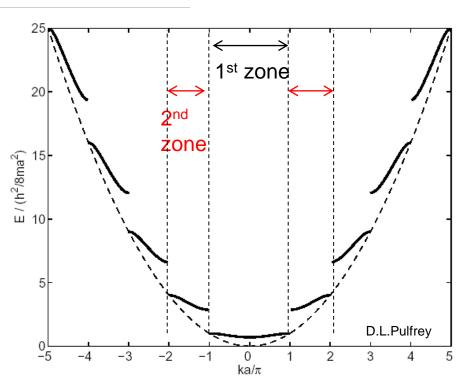
Solving this equation with appropriate boundary conditions (see p.7-9,



Allowed energy bands





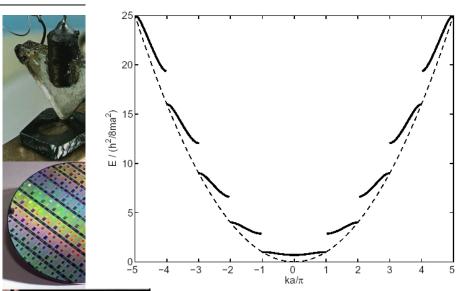




1 µm

The allowed energy is usually plotted as a function of wavevector k in the extended-zone plot. This can be compressed into a reduced zone plot.





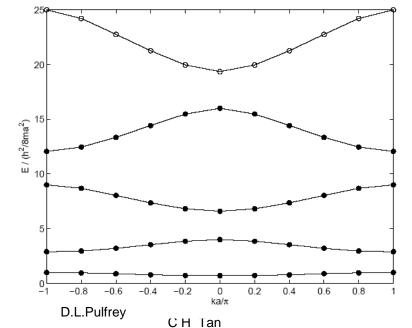
The extended zone is transformed to a reduced-zone called the Brilloun zone. Depending on the number of valence electrons present, the lower bands will be filled with electrons. In the case of Si the first 4 bands are filled with electrons. Hence the bandgap is the energy separation between the 4th and 5th bands.



1 µm

Empty states

Filled with electrons



Conduction band

Valence band

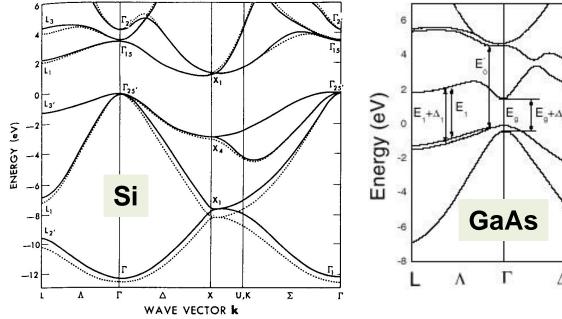


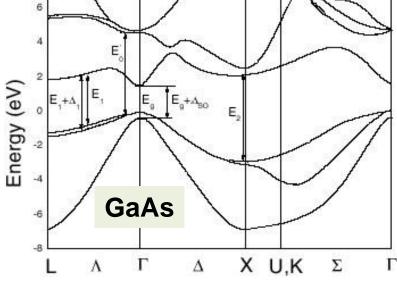




1 µm

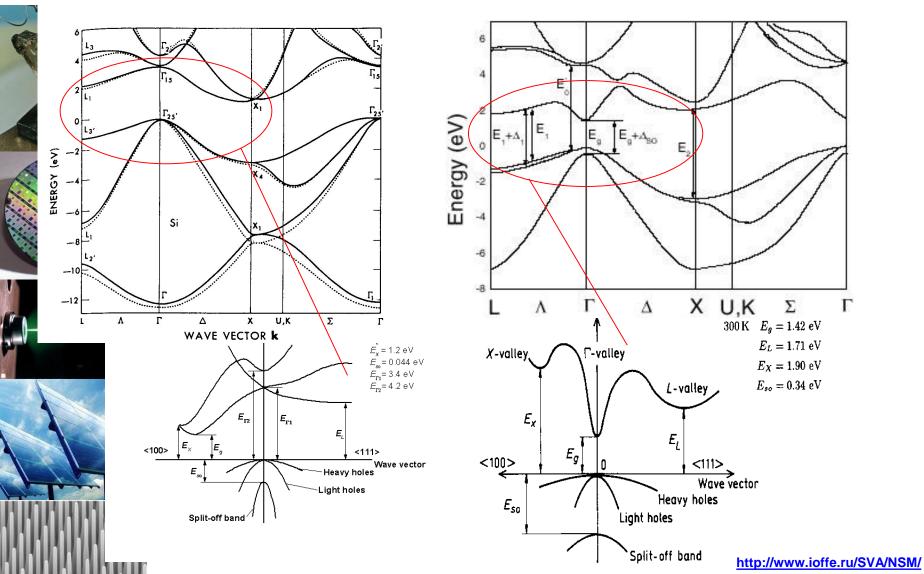
The simple 1-D example provides a conceptual illustration of how band structure is computed. In a 3-D case the potential energy is much more complicated and usually a numerical calculation is required to compute the energy versus momentum (E vs. k) band diagram.





The valence bands are relatively similar they are related to the similar bonding coordination of diamond and zinc blende. The conduction bands are more different as the electrons are "freer" than the valence electrons.

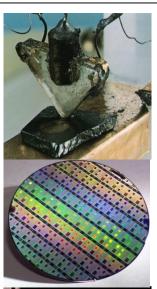


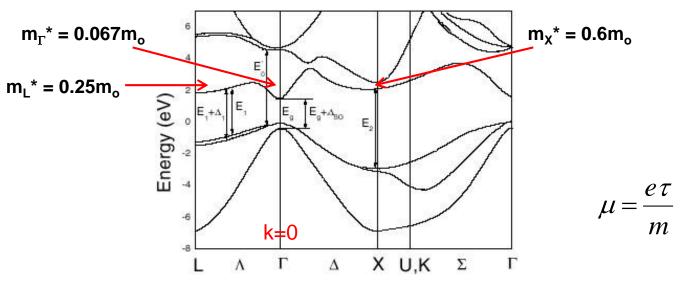


These look very different to the two band schematic earlier

1 µm









At k = 0 (Γ valley), the band structure can be described by

$$E(k) = E_C + \frac{\hbar^2 k^2}{2m^*}$$
 or $E(k) = \frac{\hbar^2 k^2}{2m^*}$ relative to E_C

Note that the effective mass m^* replaces the free electron mass m_o . For GaAs $m^* = 0.067 m_o$. A more accurate relationship is given by

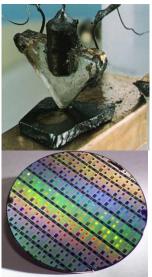
$$E(k)[1+\alpha_p E(k)] = \frac{\hbar^2 k^2}{2m^*}$$

where α_p describes the non-parabolicity of the band structure. For GaAs it has a value of 0.67 eV⁻¹.



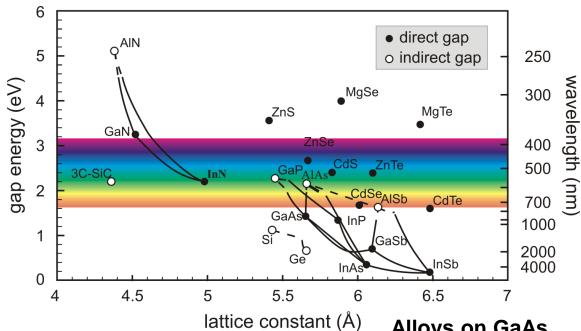


Semiconductor Alloys









Widely available substrates

InAs

IV III-V
Si GaAs
Ge InP
SiC InSb
GaSb

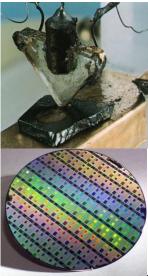
II-VI CdTe CdSe ZnSe ZnTe Alloys on GaAs
AlGaAs
InGaP
AlInP

Alloys on InP InGaAs InAIAs GaAsSb AIAsSb InGaAsP InAIGaAs

Lattice matched semiconductors form heterostructures that can be used in many electronic devices



Semiconductor alloys





To a first order approximation the alloy properties can be determined from the properties of the two materials (semiconductor A and B) combined.

$$E_{alloy}(k) = xE_A(k) + (1-x)E_B(k)$$

Band structure

$$a_{alloy} = xa_A + (1 - x)a_B$$

Lattice constant

$$\frac{1}{m_{alloy}^*} = \frac{x}{m_A^*} + \frac{(1-x)}{m_B^*}$$

Effective mass

There is a wide range of semiconductor materials that can be used in designing electronic and optoelectronic devices. Band gap, mobility, resistivity, breakdown voltage, emission (and detection) wavelength, mechanical hardness and thermal conductivity are some of the properties that can be optimised by carefully selecting the semiconductor used.

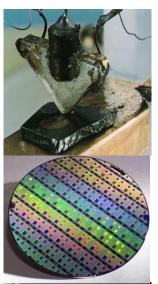
Bandgap

 $Al_{x}Ga_{1-x}As$ (1.424+1.247x)

$$In_{1-x}Ga_xAs (0.36+0.63x+0.43x^2)$$



Semiconductor properties



In addition to this **BULK** semiconductors, many properties can be modified using heterostructures and nanotechnology (quantum well, quantum dot, nanowire) as well as external force such as pressure, temperature, electric and magnetic fields.

Some of the most important heterostructures are Si/SiGe, AlGaAs/GaAs and InP/InGaAs. These are used to form the heterojunction in transistors (HBTs), lasers, photodetectors and optical modulators. They are also used to form quantum well devices.



1 µm

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